INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 15, 2026

IGI Report Number	LG844657500
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	MARQUISE BRILLIANT
Measurements	10.98 X 5.39 X 3.13 MM

GRADING RESULTS

Carat Weight	1.09 CARAT
Color Grade	F
Clarity Grade	VVS 1

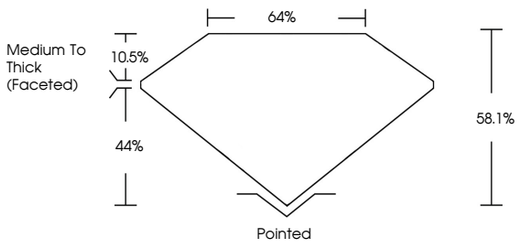
ADDITIONAL GRADING INFORMATION

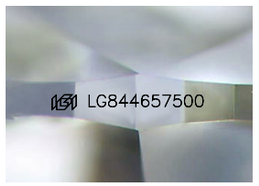
Polish	VERY GOOD
Symmetry	VERY GOOD
Fluorescence	NONE
Inscription(s)	IGI LG844657500

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG844657500
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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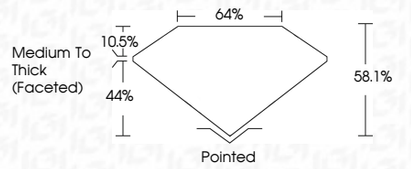
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IGI

October 15, 2026
IGI Report No LG844657500
MARQUISE BRILLIANT
10.98 X 5.39 X 3.13 MM
Carat Weight 1.09 CARAT
Color Grade F
Clarity Grade VVS 1
Depth 58.1%
Table 64%
Girdle Medium To Thick (Faceted)
Culet Pointed
Polish VERY GOOD
Symmetry VERY GOOD
Fluorescence NONE
Inscription(s) IGI LG844657500
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa